

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/668,555	VAN OOOSTERHOUT ET AL.	
Examiner	Art Unit	
Ron Schwadron, Ph.D.	1644	

SEARCHED				
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
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